From Eye to Insight



# LIGHTNING Manual

20220217\_EN\_ST

Depending on the licese, available method and wizard are different.						
	Image optimization	during	Configure	settings	for	image
	image acquisition		optimizatior	n (Afte	er	image
			acquisition)			
Lightning Process	×			0		
Lightning Expert	0			0		
Lightning	0			×		

\* LAS X Small is not available for Lightning

\* Call up Seq. and Apply are not available for Lightning wizard.

So, Call up Seq. or Apply in "STELLARIS", then go to Lightning wizard.

\* Lighting does not available for acquisition with TauSense (e.g. TauSeparation, TauSTED)

\* Lightning and Dynamic Signal Enhancement can be processed at the same time.

Then, only Lightning and DSE processed image is created, not created Lightning or DSE processed image.

		Lightning Settings			
		Lightning			
Strategy:					Adaptive 🗘
Refractive Index:					1.33000 🗢
Mounting Medium:					Water ≑
Dynamic Signal Enhancement : Frames : O Weight : O					0FF 11 ¢ 0.20 ¢ 1 ¢
Periodicity :           Expert Settings					<b>↓</b>     ★
Save settings	Open settings	Сору	)(	Paste	
3/16/2020 3:18:13 Pinformation: Stabilizing Power Outpu	Lue			Reset Cancel	Apply

## Lightning wizard

6

#### The wizard uses the Lightning or Lightning Expert license

1. Click TCS SP8 in the menu bar at the top left.

2. Select Lightning entry.

The Lightning wizard starts with **Acquire** step.

The Lightning wizard contains 5 steps.





1. You can choose among 4 scan modes in the **Acquisition Mode** dialog of the Lightning wizard.

#### xyz, xyzt, Mark and Find, Tilescan

In the Lightning wizard, sequential acquisition is enable by default. The Between Frames mode is preset as the

Pinhole	
Unit :	µm 🗘 🛛 Airy 1
Pinhole : 🔘	20,00
Emission λ [nm] : 458	20 µm = -1,00AU

scan mode in the Sequential Scan dialog. You can also acquire image using the **Between Stacks** or **Between Lines** mode. The **Pinhole** in the XY dialog: The average defined wavelength for the respective sequence is automatically applied as the **Emission**  $\lambda$  **[nm]** emission wavelength.

**3**. You have 2 options for configuring image acquisition parameter setting:

A. Coupling Speed and Resolution in the Lightning Grade dialog

1. Make sure that coupling is enabled in the **Lightning Grade** dialog. The chain has to highlighted in red. This is enable by default.

2. Drag the slider to the correct position to define whether the image is to be acquired at maximum speed (**Speed** direction) or with maximum resolution (**Resolution** direction)

Note: You can define the individual value ranges or the parameters in the Configuration steps, See Page 11, "Lightning Configuration"

B. Without coupling **Speed** and **Resolution** in the XY dialog:

- 1. Click the chain to disable coupling in the Lightning Grade dialog.
- 2. Configure your instrument parameter setting in the XY dialog.

Lightning Settings
 Lightning
Strategy:
 Adaptive
 Adaptive
 Adaptive
 Adaptive
 BestQuality
 LowSignaToNose
 Get defaults
 Cancel Calculation

4. Enter the required data for <b>Mounting Medium</b> and <b>Refractive Index</b> ,
and define the image optimization strategy

Adaptive	On the basis of the SNR, the setting for optimum image are	
	determined automatically	
Global	This strategy is recommended as default for all image	

5. There are 2 buttons for live mode at the lower edge of the screen:

Live	Enable normal live mode
Fast Live	Enable fast live mode, 512x512 pixel、600Hz、Bidirectional

6. If you execute the image acquisition by clicking Start, a data record in the original (ex.

Open projects	
e rø e rø	H
▲ Test.xlef (2.6 GB)	2 ک
<ul> <li>Lightning 001 (2.6 GB)</li> </ul>	2
Series002 (320.8 MB, xyz)	0
Series002_Lng (563.3 MB. xyz)	Ø
Series002_Lng_001 (563.3 MB, xyz)	Ø
Series002 Lng 002 (563.3 MB xvz)	<b>R</b>

Series002) and data record for the optimized images with the \_Lng ending (ex. Series002\_Lng) are created.

#### Lightning Process

The **Lightning Process** and **Lightning Expert** license gives you the option to optimize previously acquired images in the LASX outside of the lightning wizard.

This is done in the Process step:

Lightning Process	- Process menu	
Lightning Expert		
Lightning	You can change Strategy or Refractive index of mounting medium	



In the tab **Process / Lightning**, select the tool **Lightning process**. (Lightning Process license) Select **Lightning** menu (Lightning Process license)

At the bottom of the Process display window, a dialog appears the Lightning setting, and you can adjust setting here.

	Lightning Settings	0
Strategy :		Adaptive 🗘
Refractive Index :		1.44290
Mounting Medium :		Glycerol + Water 80/20 🗘
Expert Settings		0 🖈
Open from	Get defaults	Save to file

**Strategy**: Select a strategy for which application the automatic image optimization is to be executed.

Adaptive	On the basis of the SNR, the setting for optimum image are		
	determined automatically (default)		
Global	This strategy is recommended as default for all image		

If necessary, adapt the Lightning setting, for this purpose, see next page "Lightning Expert Setting".

**Expert Setting**: Opens the dialog the deconvolution parameter, see next page "Lightning Expert Setting"

Open from	Opens a file browser for selecting the file with stored setting		
Get defaults	Reset the setting to the default values.		
Save to file	Opens a file browser for selecting the storage location and		
	designation of the file.		

Click **Apply** to start the image optimization.

### Expert Settings

Expert Settings			;
	Apply to a	ll channels	
Type :			Confocal 🗘
Number of Iterations:			20 🗸 Auto
Optimization :			1.0
O			
Contrast Enhancement:			Auto
0			
Cut Off [%] :	•		🗸 Auto
0			
Regularization Parameter :			0.0500
<b>—</b> 0			
Smoothing :			Very High 🗘
Excitation Wavelength [nm] :			491
Emission Wavelength [nm] :			523
Pinhole [AU] :			0.65
Normalization :			Range 🗘
Deblurring Settings			▼
bjective			
umerical Aperture			1.1
nmersion Refractive Index:			1.33
lagnification -Offset [µm]:			40.0
			0.0
Objective Design Parameters			~
over Slip			
efractive Index			1.52
hickness [µm]:			170.0
lounting Medium			
lounting Medium			Water 4
efractive Index			1.33000
6W			)(
Save settings	Open settings	Сору	Paste

Apply to all channels	Apply parameters to all channel
Туре	Automatically selected from Confocal, STED, Passthrough
	and Multi-photon
	* Passthrough: This method automatically activated for
	acquired image with TauSense
Number of iterations	Lightning is based on an iterative algorithm. In general,
	the following applies: The higher number of iterations, the
	better the results. Large numbers of iteration, however,
	tend to lead to more artifacts, which means that there is
	always an optimal number of iterations. In the Lightning
	automatic mode, the optimal number of iterations is
	determined so that good deconvolution quality is ensured
	while also keeping artifact to a minimum. You can define
	the number of iterations yourself.
Optimization	Use this slider to adjust the intensity of the deconvolution or
	the sensitivity of the resolution (0-5). The default value is 1.
	With a value =o, a minimum deconvolution is still calculated.

Contrast Enhancement	The contrast of the measurement data is increased before
	the deconvolution. You can adjust the contrast with the
	slider (0 - 1)
Cut off (%)	Before deconvolution, voxel values below a certain threshold
	value set to 0. You can adjust the threshold value with the
	slider (0 - 1).
Regularization Parameter	This enables you to set the degree of regularization. The
	lower the value, the more severely the noise is reduced.
Smoothing	These are used to optimize the processing noisy images.
	These are 7 optimization level available (Automatic, None,
	Very Low, Low, Medium, High, Very High) for smoothing
	the initial image. If an image is very noisy, it is advisable to
	set the optimization to High.

Excitation Wavelength (nm)	Wavelength of the excitation laser.
Emission Wavelength (nm)	Detected wavelength which lie at a distance of
	15% from the left edge of the detection range
pinhole (AU)	The width of the pinhole. This is usually
	configured to 1 AU.
Normalization	Select how the signal value are scaled from 2
	methods
Range	Scaled in a 16-bit range. The signals remain
	available, since they are standardization by sum
	total of intensity.
Photon Count	Scaled in terms of the detected number of photons
	that survive. Hence, the result is quantifiable in
	regards to the detected photons.
Deblurring Settings	Any fuzzy structures resulting from the out-of-
	focus blur, for example, are removed after
	deconvolution. This is especially effective for
	STED, MP and DLS images. This function is
	deactivated by default.
Enable	Activate the function by checking the checkbox
Object Size (nm)	Using this parameter, the effect of the <b>Deblurring</b>
	is adjusted. The lower the value, the finer the
	structures that remain after image optimization.
	Don not set the value smaller than the size of the
	structures that you want to identify.
Objective	Adapt the following preset values individually for
	your experiments.
Numerical Aperture	Numerical Aperture NA
Immersion Reflective Index	Refractive index of the immersion medium for the
	objective
Magnification	Objective magnification
Z-Offset (μm)	z-position during the start of the acquisition
	relative to the coverglass.
Objective Design Parameters	The value of the objective characteristic and the
	coverglass are preset here and cannot be
	changed

	Immersion Reflective	Index	Refractive index of the immersion medium for the
	Design		objective
	Cover Slip Thickness Desi	gn	Thickness of the coverglass
	Cover Slip Reflective	Index	Refractive index of the coverglass for the objective
	Design		
Co	ver Slip		
F	Refractive Index		Refractive index of the utilized immersion medium
			for the objective
٦	Γhickness (μm)		Thickness of the coverglass
Мо	ounting Medium		
Ν	Mounting Medium		Select the utilized mounting medium from the
			dropdown menu here
F	Refractive index		Refractive index of the mounting medium
Sa	Saving and Loading Setting		You can save the setting made and reload them
			for additional experiments. To do so, the
			following button are available
0	Open from file		Opens a file browser for selecting the file the
			stored settings.
S	Save to file		Opens a file browser for selecting the location and
			designation of the file

\* Batch Processing

Select all raw data by pressing the Control key while making your selection, then Apply.

#### STED

If you selected the **STED** method under the type **STED Setting**, the following STED parameters are displayed.

Expert Settings				
CH 1				
[	Apply to a	all channels		
				sted \$
Number of iterations :				🖌 Aut
				12
	0			
				🗸 Au
				🗸 Au
Regularization Parameter :				0.050
-0				
Optimization :			Very	rhigh 🗘
Excitation Wavelength [nm] :				92
Emission Wavelength (nm) :				510
				7.7
			4	lange ‡
Post-Deblurring				
STED Settings				<b>^</b>
				775
Depletion Power [%]:				52.00
Saturation Factor:				Auto
Excitation Laser Mode:				ied ∓
Depletion Laser Mode: Axial Percentage (%):			Pub	ed Ŧ
Drift Correction:				
Gated:				
				0.500
				6.000

Depletion Wavelength [nm]	Depletion wavelength	
Depletion Power [%]	Intensity of the depletion laser	
Saturation Factor	The saturation factor indicated how intensely the	
	fluorescence is suppressed by the depletion laser. If the	
	Auto check box for the automatic configuration is disable,	
	you can adjust the saturation factor in the input fields.	
Excitation Laser Mode	Dropdown menu for selecting of the laser mode for	
	excitation: Pulsed ( <b>Pulsed</b> ) or continuous ( <b>CW</b> )	
Depletion Laser Mode	Dropdown menu for selecting of the laser mode for	
	excitation: Pulsed ( <b>Pulsed</b> ) or continuous ( <b>CW</b> )	
Axial Percentage [%]	Indicates the ratio of the intensities of the axial and lateral	
	STED laser (0: only lateral; 1: only axial)	
Drift Correction	In the event of cell movements, this compensates a linear	
	drift in the xy-direction for the image capture of z-stacks.	
Gated	When the function is enabled, the detection is carried out	
	within a defined time gate. Only the photon that reach	
	the detector during this time gate are detected.	
Gate Start [ns]	Start of the time gate	
Gate End [ns]	End of the time gate	

#### Multi-Photon

If you selected the **Multi-Photon** method under the type of **Multi-Photon Settings**, the following multi-photon parameters are displayed.

•	Expert Settings		* 0
	CH 1	CH 2	
	Apply to a	all channels	
	Type :		Multi-Photon 🗘
	Number of iterations :		✓ Auto
	Sensitivity :		1.5
	O Contrast Enhancement :		Auto
	0		
	Cut Off [%] :		🗸 Auto
	0		
	Regularization Parameter :		0.0500
	<b>—</b> 0		
	Optimization :		Very high 🗘
	Excitation Wavelength [nm] :		920
	Emission Wavelength [nm] :		510
	Pinhole (AU) :		7.77
	Normalization :		Range 🗘
	Post-Deblurring		
	Multi-Photon Settings		<b>A</b>
T	Internal Detector:		
T	Photon Count:		÷)
TL	1/		

Internal Detector	You can set with which detectors the multiphoton system should
	work. When the function is activated, the detection performed with
	internal detection (descanned detection), when deacvated, with
	external detection (non-descanned detection).
Photon Count	You select whether the excitation should be done with 2 or 3 photons.

#### DLS

#### **Light-Sheet Settings**

If the system has the **Lightning DLS** license, an additional dropdown menu is displayed. You can adjust the following parameters for Lighsheet acquisitions here:

If only the Lightning DLS license is available, but not the Lightning Expert or Lightning **Process license**, then under Expert Settings only the parameters for **Deblurring Settings** and **Light-Sheet Settings** are displayed and can be edited.

Excitation Wavelength [nm] :	633
Emission Wavelength [nm] :	653
Pinhole [AU] :	1.00
Normalization :	Range 🗘
Deblurring Settings	▼]
Light-Sheet Settings	▼]

Illumination NA	Numerical aperture of the illumination objective
Illumination	Axial shift of the light sheet relative to the axial focus position
Position	

#### Lightning Configuration

In this dialog, you can configure the specific value ranges for the parameters of the **Lightning Grade** slider.



Dragging the grab points on the sliders change the limit values. Alternatively, you can enter that fill within the specified value ranges into the input fields or change them by clicking the arrow keys.

Lightning Settings		
Pinhole AU :	0.50 🗢	1.50
XY Oversampling :	1.00 🗢 💿	2.00   \$
Z Oversampling :	0.50 🗢 🔘	1.50   \$
Line Average/ Accumulation :		4 \$
Speed :	400 🗢 🔿	1000   \$

Pinhole AU	Image resolution in the xy-direction. The value specified here
	correspond to a multiplication factor that is applied to the parameters
	configured in the <b>Acquire</b> step for image resolution. You can use this
	function to acquire images with the maximum conductive resolution for
	image optimization.
XY	Image resolution in the xy-direction. The value specified here
Oversampling	correspond to a multiplication factor that is applied to the parameters
	configured in the <b>Acquire</b> step for image resolution. You can use this
	function to acquire images with the maximum conductive resolution for
	image optimization.
Z	Image resolution in the z-direction. The value specified here
Oversampling	correspond to a multiplication factor that is applied to the parameters
	configured in the <b>Acquire</b> step for image resolution. You can use this
	function to acquire images with the maximum conductive resolution for
	image optimization.
Line Average /	In HyD detectors with Analog or Digital method, the slider in the
Accumulation	Lighting Grade dialog affects the Line Average function.
	In HyD detector with Counting method, the slider affects the Line
	Accumulation function, which is more suitable for counting photons.
Speed	You can select the scan speed for image acquisition

#### Tips

\* Iteration: The higher number of iterations, the better the results. Large number of iterations, however, tend to lead to more artifacts. You can identify the iteration number from Properties.



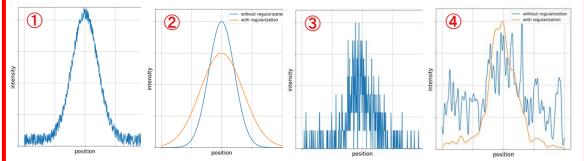
\* Smoothing: There are used to optimize the processing of noisy images. Six optimization levels are available for smoothing the initial imaging. If an image is very noisy, it is advisable to set the optimization High or Very High.

For image with high S/N no regularization is necessary. For image with low S/N, no or low regularization can cause noise to interpret as signal and appear as an artifact in the image. High S/N None > Very Low > Low > Normal > High > Very High Low S/N

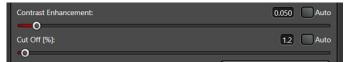
Optimization:	Medium 🗘

((4))((2))

Result of LIGHTNING at High S/N. Intensity distribution at High S/N before (①) and after LIGHTNING(②). Result of LIGHTNING at Low S/N. Intensity distribution at Low S/N before(③) and after LIGHTNING(④). W/O regularization (Blue), w/ regularization (Orange).



\* Cut Off: Before LIGHTNING, the set threshold value is subtracted from all voxels. This improved the result of the deconvolutions.



\* Batch process:

Select files while pressing CTRL key and Apply LIGHTNING.

\* Reflactive index of mount media

Mounting Medium	Refractive Index
Water	1,333
100% PBS	1,335
Glycergel®	1,38
50% Vectashield <sup>®</sup> + 50% PBS	1,39
50% PBS + 50 % Glycerol	1,406
80% Glycerol + 20 % Water	1,451
100% Vectashield ®	1,452
Mowiol®	1,46
ProLong <sup>®</sup> Gold / Diamond	1,47
Kaiser's Glycerol Jelly	1,47
Fructose (80,2%)	1,49
DPX	1,525
CFM-3	1,52
ProLong <sup>®</sup> Glass	1,52
TDE	1,33 – 1,52